AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

This listing of claims will replace all prior versions, and listings, of claims in the application:

- 1.-63. Canceled.
- 64. (Currently Amended) A nitride semiconductor light-emitting device comprising:

an n-type layer comprising an n-type GaN or and n-type nitride semiconductor containing indium and gallium;

a first p-type clad layer comprising a p-type InGaN containing indium and gallium;

an active layer, provided between said n-type and <u>first p-type nitride</u> semiconductorclad layers, having a multi-quantum well structure having a well layer comprising a nitride semiconductor represented by $In_xGa_{1-y}N$, $0 \le y < 1$ $In_xGa_{1-x}N$, 0 < x < 1;

a second p-type clad layer made of a p-type AlGaN containing Al and Ga provided over said first p-type clad layer; and

a p-type contact layer formed of a p-type GaN provided over said second p-type clad layer.

65. Canceled.

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66. (Previously Presented) The device according to claim 71, further comprising a p-type contact layer formed of a p-type GaN provided over said second p-type clad layer, and an n-type contact layer formed of an n-type GaN and over which said second n-type clad layer is provided.

67.-70. Canceled.

71. (Previously Presented) A nitride semiconductor light-emitting device comprising:

a first n-type clad layer comprising an n-type nitride semiconductor containing indium and gallium;

a first p-type clad layer comprising a p-type InGaN containing indium and gallium;

an active layer provided between said first n-type and p-type clad layers and having a multi-quantum well structure including a well layer comprising a nitride semiconductor represented by $In_xGa_{1-x}N$, where 0 < x < 1, and a barrier layer comprising a nitride semiconductor represented by $In_xGa_{1-x}N$, where $0 \le y < 1$;

a second n-type clad layer comprising an n-type nitride semiconductor containing aluminum and gallium, said second n-type clad layer having a larger band gap than said first n-type clad layer, said second n-type clad layer being provided over said first n-type clad layer; and

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a second p-type clad layer comprising a p-type AlGaN containing aluminum and gallium, said second p-type clad layer having a larger band gap than said first p-type clad layer, and said second p-type clad layer being provided over said first p-type clad layer.